



IFW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Shoichi FURUHATA

Serial No.: 10/797,923

Filed: March 10, 2004

Title: SEMICONDUCTOR WAFER,
SEMICONDUCTOR DEVICE, AND PROCESS
FOR MANUFACTURING THE
SEMICONDUCTOR DEVICE

Group Art Unit: 2826

Examiner: Thomas L. Dickey

Attorney Docket No.: FUJI:300

Certificate of Mailing

I hereby certify that this paper is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

Date:

03/30/05

By:

Marc A. Rossi

COMMISSIONER FOR PATENTS
P.O. Box 1450
ALEXANDRIA, VA 22313-1450

RESPONSE TO ELECTION / RESTRICTION

Sirs:

In response to the Election / Restriction requirement dated March 04, 2005, applicants wish to elect Group II, claims 1 to 9 for prosecution.

Respectfully submitted,

ROSSI, KIMMS & McDOWELL LLP

Marc A. Rossi

Marc A. Rossi
Reg. No. 31,923

P.O. BOX 826
Ashburn, VA 20146-0826
703-726-6020 (Phone)
703-726-6024 (fax)

03/30/05
Date